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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 1617**
Shinsuke YAMANAKA et al. : Attorney Docket No. 2005_0973A
Serial No. 10/540,231 : Group Art Unit 1794
Filed August 1, 2005 : Examiner Shawn R. Hutchinson
OXIDE NANOSTRUCTURE, METHOD FOR : **Mail Stop: AMENDMENT**
PRODUCING SAME, AND USE THEREOF

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 25-0375

Sir:

In response to the Restriction Requirement dated March 18, 2008, Applicants hereby elect the invention identified as Group I i.e. claims 65 to 83.

Favorable action on the merits is now requested.

Respectfully submitted,

Shinsuke YAMANAKA et al.

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